S&P Global EWB Standard Database Registration and Login Instructions

Ming Chi University of Technology Library July 2023 update

Introduction

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Duration	2023/7/6 ~ 2024/7/5
Content	 Standard Database: Includes a catalog of approximately 1.6 million standards from major standard organizations worldwide. Ming Chi Subscriptions: Provides access to approximately 60 subscribed standards, available for download full texts and printout. Abstract Access: For non-subscribed standards, only the abstracts are accessible.
Usage	 Service available for Ming Chi students, faculty, and staff Create a personal account using your Ming Chi email during registration Jupon registration completion, log in to your personal account to search and download full texts
Note	 Email authentication required, IP authentication not supported Registration and usage are available off-campus as well

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Create Your Account	
Enter your organizational email	
.mcut.edu.tw	
To continue, we will send a verification code to your email. I am not robot reCAPTCHA 隱私權 - 條款	
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- For students: studentID@mail2.mcut.edu.tw
- For faculty and staff: your-email@mail.mcut.edu.tw
- Note: @o365.mcut.edu.tw is also acceptable

Activate your account by following these steps:

Check your Ming Chi email for the Activation Code



Enter the Activation Code



Enter your name



Create a password



Login to your account



Accessing Engineering Workbench

Once logged in, access the Engineering Workbench by Clicking on "Engineering Workbench"

Home | Subscriber Login | How To Subscribe | Standards Store ACCURIS Main Menu Welcome, Wen-Chi [User ID: Ming Chi University Of Account: → Subscriber Logout Technology Account ID: Session: Your IP: 122.146.93.28 Select a Service from your current subscription: Engineering Workbench Support and Training The Accuris Web site, the database services, and other information provided through this Web site are made available to users subject to the Subscriber's compliance without modification of the Accuris Internet Terms and Conditions By

and notices contained herein. accessing or using this site or the Accuris database services, the Subscriber agrees to be bound by the Accuris Internet Terms and Conditions and notices.

Proceed to account settings



Customize the language settings by Selecting "Language Settings"

Engineering Workbench				
٢	Search Configurations	Interface Set Language Select Theme		
	Interface	Apply Changes Restore Defaults		
	Optional Plug-ins	Language Selection		
۲	My Groups	English (English)		
		Title Language Display Preferences for Standards If a standard has a title in different languages, the language highest in your preference order will be shown.		
		English		

Change the language as desired



Access MCUT subscriptions by navigating to: "My Subscriptions"

Engineering Workbench			🗣 🔒 Wen-Chi Ke
۲	Search Configurations	Interface Set Language Select Theme	My Settings My Subscriptions
	Interface	Apply Changes Restore Defaults	My Requests
	Optional Plug-ins	Language Selection	Shopping Cart
۲	My Groups	This sets the language for controls, labels, buttons, etc. Online help is available in English only. English (English)	About Main Menu
		Title Language Display Preferences for Standards If a standard has a title in different languages, the language highest in your preference order will be shown.	Logout

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Engineering Workbench



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ELECTROMAGNETIC COMPATIBILITY (EMC) – Part 3-3: Limits – Limitation of voltage changes, voltage fluctuations and flicker in public low-voltage



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ELECTROMA By International	AGNETIC COMPATIBI « Electrotechnical Commissi	S&P Global Notice	
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Revision Gr	roup (2)	Accept Decline	
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